Course Unit Descriptor

**Study Programme:** Physics

Course Unit Title: Introduction to plasma technologies

Course Unit Code: M18UPT

Name of Lecturer(s): Full Professor Zoran Mijatović

Type and Level of Studies: Master Academic Degree

Course Status (compulsory/elective): Elective

Semester (winter/summer): Summer

Language of instruction: English

Mode of course unit delivery (face-to-face/distance learning): Face-to-face

**Number of ECTS Allocated: 8** 

**Prerequisites:** Fundaments of electronics

#### **Course Aims:**

To teach students about the main aspects plasma technologies.

# **Learning Outcomes:**

Capability to perform experimental work. Understanding of plasma sources and application in different technological and industrial processes.

### **Syllabus:**

Theory

Treatment of surfaces by plasmas. Ions-solids interactions. Thin film deposition by plasmas. Plasma etching in microelectronics. Material processing by plasmas. Plasma chemistry. Plasma light sources.

#### Practice

Electrical characteristics of pulsed plasma sources. Spectral characteristics of pulsed plasma sources. Spectral characteristics of DC arc plasma. Spectral characteristics of glow discharge. Glass metalization by plasmas.

## **Required Reading:**

- 1. J. R. Roth, Industrial Plasma engineering, Vol. 1, IoP, Bristol, 1995.
- 2. J. R. Roth, Industrial Plasma engineering, Vol. 2 IoP, Bristol, 2001.

Weekly Contact Hours: Lectures: 3 Practical work: 2

### **Teaching Methods:**

Lectures and students group work

## **Knowledge Assessment (maximum of 100 points):** 100

Pre-exam obligations	points	Final exam	points
Active class participation	5	written exam	
Test I and Test II	15	oral exam	70
Preliminary exam(s)	5		
Seminar(s)	5		

The methods of knowledge assessment may differ; the table presents only some of the options: written exam, oral exam, project presentation, seminars, etc.